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DEC-04-03 11:43 FROM:HONEYWELL LAW DEPT

TO: 917037469195

PAGE: 001/005

Honeywell

Law Department 67-15/2102-406 1944 E. Sky Harbor Circ. Phoenix, AZ 85034

TO: Office of Initial Patent Examination's

FAX NO.: 1-703-746-9195

Filing Receipt Corrections

COMPANY: USPTO

TOTAL 5

DATE: December 2, 2003

PAGES:

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If all pages aren't received please call Jean, 602-365-2506

FROM:

B

Robert Desmond, Esq.

Telephone: (602) 365-2588

FAX: (602) 365-2490

RE: Request for Correction of Official Filing Receipt

Serial No.: 10/621,168 Filing Date: 7/15/03

Applicant: Chien-Wei LI et al. Sintered Silicon Nitride Title:

Enclosed is a Request for Correction of Official Filing Receipt for the above-identified patent application.

Please call me at 602-365-2588 if you have any questions regarding processing the Request.

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#### UTILITY PATENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Chien-Wei LI et al.

Group Art Unit: 1775

Serial No.:

10/621,168

Examiner: Unknown

Filed:

July 15, 2003

Attorney Docket No.: H0005036

For:

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by Signature

Robert Desmond

### REQUEST FOR CORRECTED FILING RECEIPT

Commissioner of Patents P.O. Box 1450 Arlington, VA 22313-1450

Sir:

Applicants are in receipt of the official Corrected Filing Receipt, dated November 19, 2003, for the above-identified application, and have noted an error thereon. Specifically, Applicants note that Applicant Bjoern Schenk's name is misspelled as "Bjoern Schenk" when it should be "BJOERN SCHENK."

Applicants respectfully request that Applicant Bjoern Schenk's name be corrected, as annotated on the attached copy of the Corrected Filing Receipt, and that a corrected Filing Receipt be issued with the correct spelling of Applicant Schenk's name.

Should the Office of Initial Patent Examination's Filing Receipt Corrections have any questions, Applicants request that the Examiner contact the undersigned at (620) 365-2588.

Respectfully submitted,

Dated 12/4/03

Robert Desmond, Esq. Attorney for Applicants Registration No. 38,430

Honeywell International, Inc. Law Dept. AB2 101 Columbia Road P.O. Box 2245 Morristown, NJ 07962-2245 Telephone: (602) 365-2588

Facsimile: (602) 365-2490

(c) DATE



#### United States Patent and Trademark Office

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H0005036

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CAM-SHX-1C DEC 0 1 2003

**CONFIRMATION NO. 3525** CORRECTED FILING RECEIPT \*OC000000011304766\*

Date Mailed: 11/19/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filling Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt Incorporating the requested corrections (if ENTRAL RECORDS - MTO appropriate).

BJOERN

Applicant(s)

Chien-Wei Li, Livingston, NJ; Bjeem Schenk, Phoenix, AZ; James V. Guiheen, Madison, NJ;

Assignment For Published Patent Application

Honeywell International Inc., Momistown, NJ;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 10/17/2003

Projected Publication Date: 01/20/2005

Non-Publication Request: No

Early Publication Request: No

Title

Sintered silicon nitride

\* DURATION (mm-ss):01-542-4-1-53

Preliminary Class

428

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